

CERTIFICATE OF MAILING

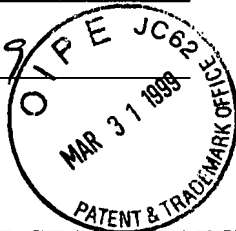
I hereby certify that this paper or fee is being deposited with the United States Postal Service as first class mail in an envelope addressed to: the Assistant Commissioner for Patents, Box AF, Washington, D.C. 20231 on March 29, 1999

Kent E. Genin, Reg. No. 37,834

Name of Applicant, assignee or Registered Representative

Signature of above

Date of Signature



**Response Under 37 CFR 1.116
Expedited Procedure
Examining Group 3723**

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APR 02 1999

Group 3700

**PATENT
CASE NO. 7103/30**

12pmd+E
(NE)
4/2/99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)

Homayoun Talieh et al.)

Serial No.: 08/853,323)

Filed: May 8, 1997)

For: LINEAR POLISHER AND)
METHOD FOR)
SEMICONDUCTOR WAFER)
PLANARIZATION)

Examiner: G. Nguyen

Group Art Unit: 3723

AMENDMENT UNDER 37 C.F.R. §1.116

Assistant Commissioner for Patents
Box AF
Washington, D.C. 20231

Dear Sir:

In response to the final Office Action dated January 27, 1999 please enter the following amendment and consider the following remarks:

IN THE CLAIMS:

Please amend claims 32, 34, 36-38, and 40 as follows: